This Page Is Inserted by IFW Operations and is not a part of the Official Record

BEST AVAILABLE IMAGES

Defective images within this document are accurate representations of the original documents submitted by the applicant.

Defects in the images may include (but are not limited to):

- BLACK BORDERS
- TEXT CUT OFF AT TOP, BOTTOM OR SIDES
- FADED TEXT
- ILLEGIBLE TEXT
- SKEWED/SLANTED IMAGES
- COLORED PHOTOS
- BLACK OR VERY BLACK AND WHITE DARK PHOTOS
- GRAY SCALE DOCUMENTS

IMAGES ARE BEST AVAILABLE COPY.

As rescanning documents will not correct images, please do not report the images to the Image Problem Mailbox.

INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(51) International Patent Classification 6: H05K 1/16

(21) International Application Number:

A1

(11) International Publication Number:

WO 99/45753

(43) International Publication Date: 10 September 1999 (10.09.99)

(22) International Filing Date:

5 March 1999 (05.03.99)

PCT/SE99/00325

(30) Priority Data:

9800707-3

5 March 1998 (05.03.98)

SE

(71) Applicant (for all designated States except US): ETCHTECH SWEDEN AB [SE/SE]; Per Albin Hanssons vag 41, S-205 12 Malmö (SE).

(72) Inventor; and

(75) Inventor/Applicant (for US only): WIKSTROM, Bo [SE/SE]; Jaktstigen 10, S-261 75 Asmundtorp (SE).

(74) Agent: AWAPATENT AB; P.O. Box 5117, S-200 71 Malmö

(81) Designated States: AL, AM, AT, AT (Utility model), AU, AZ, BA, BB, BG, BR, BY, CA, CH, CN, CU, CZ, CZ (Utility model), DE, DE (Utility model), DK, DK (Utility model), EE, EE (Utility model), ES, FI, FI (Utility model), GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MD, MG, MK, MN, MW, MX, NO, NZ, PL, PT, RO, RU, SD, SE, SG, SI, SK, SK (Utility model), SL, TJ, TM, TR, TT, UA, UG, US, UZ, VN, YU, ZW, ARIPO patent (GH, GM, KE, LS, MW, SD, SL, SZ, UG, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, CH, CY, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GW, ML, MR, NE, SN, TD, TG).

Published

With international search report.

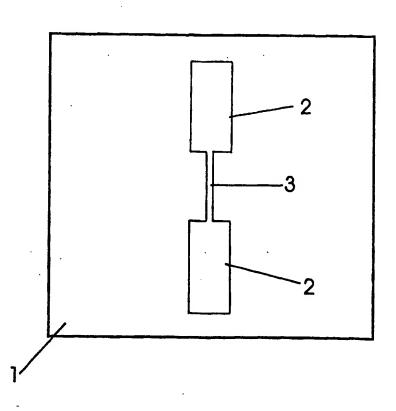
Before the expiration of the time limit for amending the claims and to be republished in the event of the receipt of amendments.

In English translation (filed in Swedish).

(54) Title: METHOD FOR MANUFACTURING A RESISTOR

(57) Abstract

A method for manufacturing a resistor function in an electric conductor on the surface of a carrier, preferably a conductor on printed circuit boards, substrates and chips. By etching using an anisotropic etching technique, the conductor is provided with at least one portion which has a smaller cross-sectional area than the conductor surrounding the portion, the length and width of the portion being such that a predetermined resistance is obtained in the conductor. A resistor according to the invention is on both sides connected to a conductor on a carrier, such as a printed circuit board, a substrate or a chip. The resistor comprises a conductor portion positioned on the carrier and having a significantly smaller cross-sectional area than the conductor on both sides of the resistor.



FOR THE PURPOSES OF INFORMATION ONLY

Codes used to identify States party to the PCT on the front pages of pamphlets publishing international applications under the PCT.

AL	Albania	ES	Spain	LS	Lesotho	Si	Slovenia
AM	Armenia	Fl	Finland	LT	Lithuania	SK	Slovakia
AT	Austria	FR	France	LU	Luxembourg	SN	Senegal
AU	Australia	GA	Gabon	LV	Larvia	SZ	Swaziland .
AZ.	Azerbaijan	GB	United Kingdom	MC	Monaco	TD	Chad
BA	Bosnia and Herzegovina	GE	Georgia	MD	Republic of Moldova	TG	Togo
BB	Barbados	GH	Ghana	· MG	Madagascar	ŢĴ	Tajikistan
BE	Belgium	GN	Guinea	MK	The former Yugoslav	TM	Turkmenistan
BF	Burkina Faso	GR	Greece		Republic of Macedonia	TR	Turkey
BG	Bulgaria	HU	Hungary	ML	Mali	TT	Trinidad and Tobago
BJ	Benin	IE.	freland	MN	Mongolia	UA	Ukraine
BR	Brazil	IL	Israel	MR	Mauritania	UG	Uganda
BY	Belarus	IS	Iceland	MW	Malawi	us	United States of America
CA	Canada	IT	Italy	MX	Mexico	UZ	Uzbekistan
CF	Central African Republic	JP	Japan	NE	Niger	VN	Viet Nam
CG	Congo	KE	Kenya	NL	Netherlands	YU	Yugoslavia
CH	Switzerland	KG	Kyrgyzstan	NO	Norway	zw	Zimbahwe
CI	Côte d'Ivoire	KP	Democratic People's	NZ '	New Zealand	200	Zaurozowe
CM	Cameroon		Republic of Korea	PL	Poland		
CN	China	KR	Republic of Korea	PT	Portugal		
CU	Cuba	KZ	Kazakstan	RO	Romania		
CZ	Czech Republic	LC	Saint Lucia	RU	Russian Pederation		
DE	Germany	LI	Liechtenstein	SD	Sudan		
DK	Denmark	LK	Sri Lanka	SE	Sweden		
EE	Estonia	LR	Liberia	SG	Singapore		

15

20

25

30

METHOD FOR MANUFACTURING A RESISTOR

Field of the Invention

The present invention relates to a resistor and a method for manufacturing a resistor on carriers, preferably printed circuit boards, substrates and chips with or without integrated circuits, in the field of electronics.

Background Art

Printed circuit boards, substrates or chips have conductor structures on their surfaces or inside to connect other components, integrated functions or to connect to the surroundings. If resistor components are required, they are mounted as discrete components or applied as resistor pastes to printed circuit boards, substrates or chips so as to achieve the necessary resistance.

This is a time-consuming and complicated process. Therefore there is a need for a process which facilitates the manufacture of resistors.

Summary of the Invention

An object of the present invention is to overcome the above drawbacks and render the realisation of the resistor function in electronic products such as printed circuit boards, substrates and chips more effective.

These objects are achieved by a resistor and a method according to the appended claims.

A method for manufacturing a resistor function in an electric conductor on the surface of a carrier, preferably conductors on printed circuit boards, substrates and chips, according to the invention is characterised in that the conductor, by etching using an anisotropic etching technique, is provided with at least one portion which has a smaller cross-sectional area than the conductor on both sides of the portion, the length and width of the portion being such that a predetermined resistance is obtained in the conductor.

15

20

35

A resistor which on both sides is connected to a conductor on a carrier, such as a printed circuit board, a substrate or a chip, according to the invention is characterised in that the resistor comprises a conductor portion which is positioned on the carrier and which has a significantly smaller cross-sectional area than the conductor on both sides of the resistor.

By a significantly smaller cross-sectional area is meant that the cross-sectional area is smaller than 20%, preferably smaller than 5% of the cross-sectional area of the conductor.

A method according to the invention is based on the use of an anisotropic etching technique to generate conductor structures having a desired resistance.

By the resistor function being achieved by the conductor being provided with a portion of a smaller cross-sectional area, the resistor function can be made at the same time as the conductor structure on, for instance, a printed circuit board is made.

By the forming of the resistor function according to a preferred embodiment occurring in the normal conductor path, the resistor function can also be integrated in the internal conductor layers in multilayer printed circuit board or substrates, which causes improved distribution of the thermal energy generated by the resistor function.

According to a preferred embodiment of the present invention, the reduced cross-sectional area is a reduction of the width of the conductor in the plane of the surface. The desired resistance is then obtained by an adaptation of the width of the conductor or by adaptation of the length of the narrowed portion.

The conductors are preferably formed with a narrowed portion which has been etched by an anisotropic etching technique, to such a conductor width that such a noticeable resistance level is obtained that other resistor functions are not necessary in the extent of the conduc-

35

tor path between the other component connections to which an applied resistor function would have been connected.

According to an alternative embodiment of the present invention, the reduced cross-sectional area is provided by at least one essentially longitudinal groove being etched in the surface of the conductor. If the grooves are etched through the entire conductor, at least two essentially parallel conductors are obtained.

A person skilled in the art realises that the anisotropic etching technique is selected among known anisotropic etching techniques. The specific application
determines which etching technique is to be chosen. Examples of anisotropic etching techniques are reactive ion
etching, plasma etching and different kinds of wet etching.

According to a preferred embodiment of the present invention, use is made of a wet etching technique. This is advantageous from the viewpoint of costs.

According to a special aspect of the invention, use is made of a chemically etching etching fluid, in which the etchant, which constitutes the active substance, is present in a diluted solution. Extremely good results can be produced, such as exact etchings in small dimensions. This aspect of the invention is based on the surprising discovery that an etching fluid which has been diluted to have a negligible etching effect can be used for anisotropic etching under the action of an electric field.

This results in etching of an electrically conductive etching material by means of an etchant, which is present in a solution which is diluted to such a great extent as not to be practically usable for chemical etching. The etchant concentration is so low that such reactions between the etchant and the etching material as result in the removal of atoms from the etching material occur only sporadically. By an electric field being produced in the etchant solution between the electrode and a surface portion of the etching material, a local con-

10

15

25

30

centration of etchant forms on the surface portion of the etching material. This results in a pronounced increase of the etching rate of the etchant while at the same time the etching direction of the etchant is affected.

The described etching method is known from PCT Application SE97/01480.

If exact resistors are to be manufactured, it is advantageous to measure the resistance of the conductor during etching. When the measured resistance conforms with the desired value, the etching is interrupted.

The above features can, of course, be combined in the same embodiment.

In order to further elucidate the invention, detailed embodiments thereof will be described below, without the invention, however, being considered to be restricted thereto.

Brief Description of the Drawings

Fig. 1 illustrates a conductor on a printed circuit board, said conductor having a narrowed portion along 20 part of the length of the conductor path, according to an embodiment of the invention.

Fig. 2 illustrates a conductor on a printed circuit board, said conductor having a plurality of parallel conductor portions along part of the length of the conductor path, according to an alternative embodiment of the invention.

Fig. 3 illustrates a conductor on a chip, said conductor having a portion with a conductor which is narrower than the surrounding conductor portions and which is longer than the distance between the surrounding conductor portions.

Detailed Description of the Invention

Fig. 1 shows a printed circuit board, substrate or chip 1 which has a conductor 2 with a narrowed portion

5 3 to provide the intended resistance in the conductor.
As a result, no separate resistor component or resistor

pressure is required. The length and width of the narrowed portion have been adapted to produce the desired resistor. In the Figure, the narrowed portion has the same width over its entire length, but a person skilled in the art realises that the width may vary over the length.

Fig. 2a shows a printed circuit board, substrate or chip 1 which is provided with a conductor 4. Fig. 2b is a sectional view along line A-A in Fig. 2a. This is formed with etched grooves 6, which results in the conductor 2 having narrowed conductor portions 5. This, in turn, results in the desired resistance value while at the same time the distribution of current in a plurality of conductors distributes the generation of power on a larger surface. In the Figure, the grooves are etched through the thickness of the entire conductor, but alternatively the grooves extend only partly through the thickness of the conductor.

Fig. 3 illustrates a printed circuit board, sub20 strate or chip 1 which is provided with one or more conductors 2. The conductor or conductors have been formed
with a narrowed conductor portion 3 which has such a
great narrowing 3 in a conductor pattern prolonged in
relation to the distance between the conductor paths
25 which are not narrowing, in order to increase the resistance value.

By thus increasing the length of the conductor, the width can be greater for a certain predetermined resistance compared with the case where the conductor is made straight. The narrowed conductor portion has been distributed over a larger surface, which means that the generation of power is distributed on a larger surface, which in turn leads to a lower temperature of the conductor.

The conductor structure in Fig. 3 has been produced by masking and etching.

The embodiments described above are only to be regarded as examples. A person skilled in the art realises that the above embodiments can be varied in a number of ways without deviating from the inventive idea.

CLAIMS

- 1. A method for manufacturing a resistor function in
 an electric conductor on the surface of a carrier,
 preferably a conductor on printed circuit boards,
 substrates and chips, characterised in that
 the conductor, by etching using an anisotropic etching
 technique, is provided with at least one portion which
 has a smaller cross-sectional area than the conductor
 surrounding the portion, the length and width of the
 portion being such that a predetermined resistance is
 obtained in the conductor.
- 2. A method as claimed in claim 1, characterised in that the conductor is provided with
 a plurality of parallel portions whose total cross-sectional area is smaller than the cross-sectional area of
 the surrounding conductor.
- 3. A method as claimed in claim 1, characterised in that a portion of the conductor is
 etched by using an anisotropic etching technique so that
 said portion obtains a greater length and a smaller width
 than the original portion.
- 4. A method as claimed in claim 1, charac25 terised in that the reduced cross-sectional area consists of a reduction of the width of the conductor in the plane of the surface.
- 5. A method as claimed in any one of claims 1, 2, 3 or 4, characterised in that the anisotropic etching is a wet etching method, and that it further comprises the step of

performing anisotropic etching by arranging an electric field in the etching fluid adjacent to the conductor, the etching fluid being present in such a diluted solution that it is not capable of etching the conductor without an electric field, but in concentrated form etches the conductor without an electric field.

6. A method as claimed in any one of the preceding claims, characterised by the steps of measuring the resistance of the conductor during etching, and

- interrupting the etching when the measured resistance corresponds to the predetermined resistance.
- 7. A method as claimed in any one of the preceding claims, character is ed in that the conductor is coated with a further layer.
- 8. A resistor which on both sides is connected to a conductor on a carrier, such as a printed circuit board, a substrate or a chip, c h a r a c t e r i s e d in that the resistor comprises a conductor portion which is positioned on the carrier and which has a significantly smaller cross-sectional area than the conductor on both sides of the resistor.
 - 9. A resistor as claimed in claim 8, wherein the conductor portion of the resistor has been given a smaller cross-sectional area by anisotropic etching.
- 20 10. A resistor as claimed in claim 8 or 9, character is ed in that the conductor portion with a significantly smaller cross-sectional area consists of a plurality of parallel conductors whose total cross-sectional area is smaller than that of the sur-
- 25 rounding conductor.

1/3

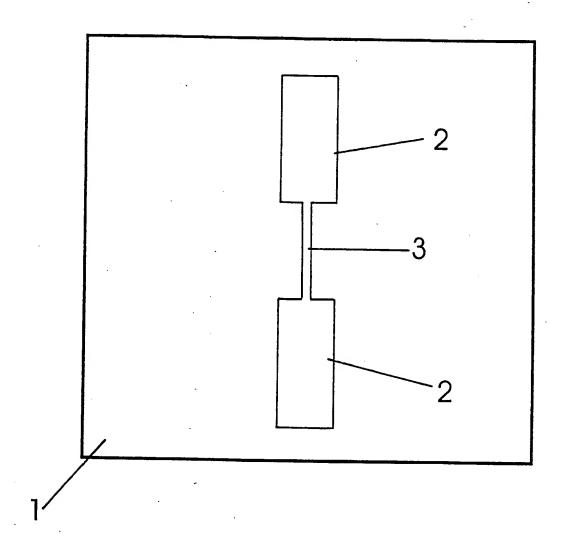
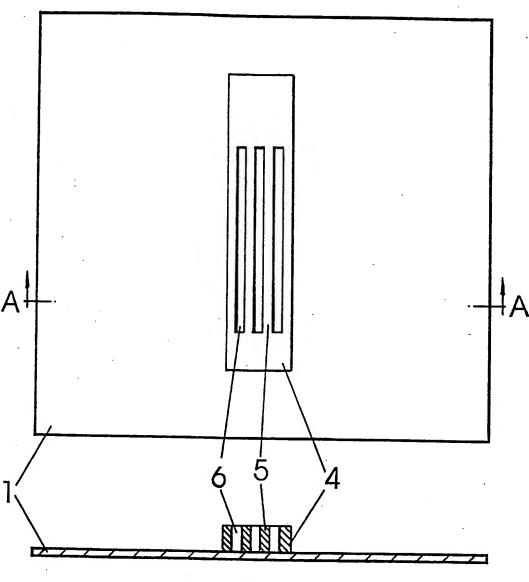


Fig. 1.

2/3

Fig. 2.a



A-A

Fig. 2.**b**

INTERNATIONAL SEARCH REPORT

International application No. PCT/SE 99/00325

A. CLASSIFICATION OF SUBJECT MATTER						
IPC6:	H05K 1/16 to International Patent Classification (IPC) or to both	national classification and IBC	·			
	DS SEARCHED	national classification and IPC				
Minimum	documentation searched (classification system followed	by classification symbols)				
IPC6:	H05K, H01L, H01C					
Document	ation searched other than minimum documentation to the	he extent that such documents are included it	n the fields searched			
	FI,NO classes as above					
Electronic o	data base consulted during the international search (name	ne of data base and, where practicable, search	h terms used)			
C. DOCL	JMENTS CONSIDERED TO BE RELEVANT					
Category*	Citation of document, with indication, where ap	opropriate, of the relevant passages	Relevant to claim No.			
A	EP 0163760 A2 (NIPPON MEKTRON L 11 December 1985 (11.12.85)	TD.),	1-10			
A	EP 0719079 A1 (KANTO KASEI CO., 26 June 1996 (26.06.96)	LTD.),	1-10			
	~~					
A	IBM Technical Disclosure Bullet 10A, March 1991; "DECOUPLIN IN PRINTED CIRCUIT BOARD"	in, Volume 33, No G CAPACITOR INCORPORATED	1-10			
P,A	EP 0837623 A1 (MACDERMID INCORPORT 22 April 1998 (22.04.98)	ORATED),	1-10			
<u>i</u>			``			
X Furth	er documents are listed in the continuation of Bo	x C. See patent family annex	4.			
* Special categories of cited documents: "A" document defining the general state of the art which is not considered to be of particular relevance "I later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention						
"E" erlier document but published on or after the international filing date "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other "E" document but published on or after the international filing date "X" document of particular relevance: the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone						
"O" document referring to an oral disclosure, use, exhibition or other considered to involve an inventive step when the document is						
"P" documer	"P" document published prior to the international filing date but later than the priority date claimed "&" document member of the same patent family					
Date of the	actual completion of the international search	Date of mailing of the international s				
		12 -0				
	5 July 1999					
	Name and mailing address of the ISA/ Swedish Patent Office Authorized officer					
Box 5055,	S-102 42 STOCKHOLM	Marianne Bratsberg/MP				
racsimile N	o. +46 8 666 02 86	Telephone No. + 46 8 782 25 00	i			

Form PCT/ISA/210 (second sheet) (July 1992)

INTERNATIONAL SEARCH REPORT

International application No.
PCT/SE 99/00325

P,A WO 9810121 A1 (OBDUCAT AKTIEBOLAG), 12 March 1998 1-10	Category*	Citation of document, with indication, where appropriate, of the relevant	Relevant to claim No.	
	P,A	WO 9810121 A1 (OBDUCAT AKTIEBOLAG), 12 March 1 (12.03.98)	998	1-10
		,		
		_		
		•		
				*
		No.	Ÿ	2
	İ			·
		* •		•
			×	
				٠
				•
			·	
		•		

3/3

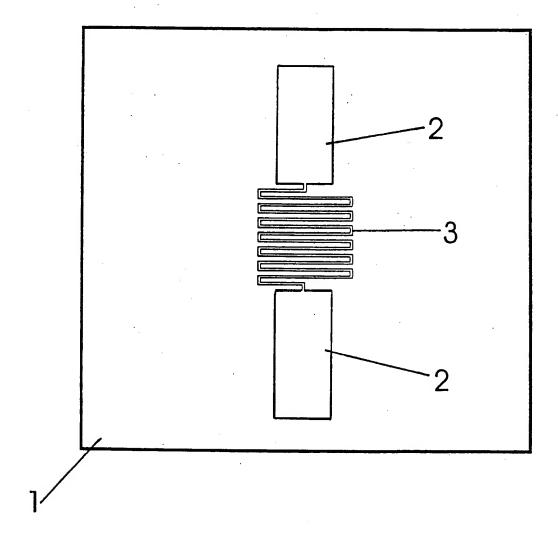


Fig. 3